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FINAL REPORT TO THE AFOSR "STUDIES IN SCANNING PROBE MICROSCOPY"

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Abstract

The following is the Final Report on our work in the field of Scanning Probe Microscopy (SPM), which has been funded by the AFOSR under Contract F49620-92-J-0164. The AFOSR funding was instrumental in the establishment of a multi-lab facility at the Optical Sciences Center, which performs research in SPM using two ultrahigh vacuum (UHV) STM facilities, and several Atomic Force Microscopy (AFM) facilities. The fabrication and characterization work performed in the SPM Laboratory is supplemented by infrared (IR) spectroscopy, high resolution transmission electron microscopy (HRTEM), and scanning electron microscopy (SEM), available in other departments. The report contains the list of our publications related to the OSR which appeared in refereed journals, as well as two books titled *Scanning Force Microscopy, With Applications to Electric, Magnetic, and Atomic Forces* published by Oxford University Press in 1991 and a revised edition in 1994.

1 Scanning Tunneling Microscopy

1.1 Semiconductors

- D. Sarid, B. P. McGinnis, and T. D. Henson, "Four-wave mixing and scanning tunneling microscopy of semiconductor clusters," SPIE 881, 114 (1988).
- D. Sarid, T. D. Henson, L. S. Bell, and C. J. Sandroff, "Scanning tunneling microscopy of semiconductor clusters," J. Vac. Sci. Technol. A 6, 424 (1988).
- D. Sarid, T. D. Henson, N. Armstrong, and L. S. Bell, "Probing of basal planes of MoS_2 by scanning tunneling microscopy," Appl. Phys. Lett. 52, 2252 (1988).
- T. D. Henson, D. Sarid, and L. Stephen Bell, "Scanning tunneling microscopy of layered-structure semiconductors," J. Microscopy 152, 467 (1988).
- D. Sarid, "Holographic display of scanning tunneling microscopy images," Opt. News, August 11 (1988).
- T. Iwabuchi, C. Chuang, G. Khitrova, M. E. Warren, A. Chavez-Pirson, H. M. Gibbs, D. Sarid, and M. Gallagher, "Fabrication of GaAs nanometer structures by dry etching," SPIE 1284, 142 (1990).
- S. Howells, M. Gallagher, T. Chen, and D. Sarid, "Oxidation effects on cleaved multiple quantum well surfaces in air observed by scanning probe microscopy," Appl. Phys. Lett. 61, 801 (1992).
- H. Gießen, B. P. Jacobsen, D. Sarid, M. Grin, U. Becker, and C. Klingshirn, "Growth of Wurtzite CdSe thin films with extremely narrow excitonic luminescence by hot wall epitaxy and their characterization," Proc. of the CLEO '93 Conference, Baltimore, MD, (May 2-7, 1993).

1.2 Optical Interactions

- M. J. Gallagher, S. Howells, L. Yi, T. Chen, and D. Sarid, "Photon emission from gold surfaces in air using scanning tunneling microscopy," Surf. Sci. 278, 270 (1992).
- M. J. Gallagher, T. G. Ruskell, D. Chen, D. Sarid, and H. Jenkinson, "Nanosecond time-scale semiconductor photoexcitations probed by a scanning tunneling microscope," Appl. Phys. Lett. 64, 256 (1994).

- T. G. Ruskell, M. J. Gallagher, D. Chen, and D. Sarid, "Nanosecond time-scale semiconductor photoexcitations probed by a scanning tunneling microscopy," *Optics and Photonics News*, December (1994).
- T. G. Ruskell, D. Chen, and D. Sarid, "Scanning tunneling microscopy of photoexcitations on a nanosecond time-scale", *Mat. Res. Soc. Symp. Proc.* (in print 1995).
- D. Sarid, "High-speed scanning tunneling microscopy," pp. 202, *McGraw-Hill Yearbook of Science and Technology*, McGraw-Hill (1996).

1.3 Biology

- D. Sarid, E. H. Thall, D. A. Iams, J. T. Ingle, T. D. Henson, Y. C. Lee, and L. S. Bell, "Scanning tip microscopy with applications to biology," *SPIE 1063*, 42 (1989).
- S. R. Hameroff, Y. Simic-Kristic, L. A. Verneti, Y. C. Lee, D. Sarid, J. Weidmann, V. Elings, K. Kjoller, and R. S. McCuskey, "STM of cytoskeletal proteins: microtubules and intermediate filaments," *J. Vac. Sci. Technol.* 8, 687 (1990).
- L. A. Verneti, C. L. A. Nowline, S. R. Hameroff, A. J. Gandolfi, Y. C. Lee, and D. Sarid, "STM resolution of surface features on cytokeatin protein is enhanced by prolonged exposure of protein to cold temperatures," *J. Vac. Sci. Technol. B* 9, 1223 (1991).
- L. A. Verneti, D. Sarid, A. J. Gandolfi, A. E. Cress, R. B. Nagle, R. McCuskey, and S. R. Hameroff, "STM images of cytokeatin and binding IgG antibody," *AIP Proc. Conf. on Scanned Probe Microscopies* 241, 232 (1992).

1.4 Fullerenes

- T. Chen, S. Howells, M. Gallagher, L. Yi, D. Sarid, D. L. Lichtenberger, K. W. Nebesney, and C. D. Ray, "Modelling of internal structure of monolayer C_{60} molecules on a gold substrate," *Mat. Res. Soc. Symp. Proc.* 208, 721 (1991).
- T. Chen, S. Howells, M. Gallagher, L. Yi, D. Sarid, D. Lichtenberger, and C. Ray, "Internal structure and two-dimensional order of monolayer C_{60} molecules observed with STM," *J. Vac. Sci. Technol. B* 9, 2461 (1991). *Also reprinted J. Vac. Sci. Technol. B* 10, 170 (1992).

- D. Sarid, T. Chen, S. Howells, M. Gallagher, L. Yi, D. Lichtenberger, and D. Huffman, "Atomic force microscopy and scanning tunneling microscopy of monolayer C_{60} molecules on a gold substrate," *Ultramicroscopy* **42-44**, 610 (1992). (See also journal covers.)
- S. Howells, T. Chen, M. Gallagher, D. Sarid, D. L. Lichtenberger, L. L. Wright, C. D. Ray, D.R. Huffman, and L. D. Lamb, "High resolution images of single C_{70} molecules on gold (111) using scanning tunneling microscopy," *Surf. Sci.* **274**, 141 (1992).
- L. D. Lamb, D. R. Huffman, R. K. Workman, S. Howells, T. Chen, D. Sarid, and R. F. Ziolo, "Extraction and STM imaging of spherical giant fullerenes," *Science* **255**, 1413 (1992).
- T. Chen, S. Howells, M. Gallagher, D. Sarid, L. D. Lamb, D. R. Huffman, and R. K. Workman, "Scanning tunneling microscopy and spectroscopy studies of C_{60} thin films on gold substrate," *Phys. Rev. B Rapid Commun.* **45**, 14411 (1992).
- T. Chen and D. Sarid, "From bucky-balls and rugby-balls to giant fullerene molecules: A scanning tunneling microscopy and spectroscopy study," *Mod. Phys. Lett. B* **6**, 967 (invited review, 1992).
- M. Gallagher, D. Chen, B. P. Jacobsen, D. Sarid, L. D. Lamb, F. Tinker, J. Jiao, R. Huffman, S. Seraphin, and D. Zhou, "Study of carbon nanotubes by scanning tunneling microscopy, atomic force microscopy and high resolution transmission electron microscopy," *Surf. Sci. Lett.* **281**, L336 (1993).
- R. Höper, R. K. Workman, D. Chen, D. Sarid, T. Yadav, J. C. Withers, and R. O. Loutfy, "Single-shell carbon nanotubes imaged by atomic force microscopy," *Surf. Sci. Lett.* **311**, L731 (1994).
- T. Chen and D. Sarid, " C_{60} adsorption on the layered compound semiconductor MoS_2 studied by scanning tunneling microscopy," *J. Vac. Sci. Technol. B* **12**, 1947 (1994).
- D. Chen and D. Sarid, "Temperature effects of adsorption of C_{60} molecules on Si(111)-7x7 surfaces," *Phys. Rev. B* **49**, 7612 (1994).
- D. Chen, M. J. Gallagher, and D. Sarid, "Scanning tunneling microscopy study of the adsorption of C_{60} molecules on Si(100)-2x1 surfaces," *J. Vac. Sci. Technol. B* **12**, 1947 (1994).

- D. Chen, J. Chen, and D. Sarid, "Single monolayer ordered phases of C_{60} molecules on Si(111)-(7 × 7) surfaces," *Phys. Rev. B* **50**, 10905 (1994).
- D. Chen and D. Sarid, "Growth of C_{60} films on silicon surfaces," *Surf. Sci.* **318**, 74 (1994).
- Dong Chen, Jian Chen, and Dror Sarid, "Si- C_{60} -Si(111)-(7×7) interactions probed by scanning tunneling microscopy," *Surf. Sci.* **321**, 190 (1995).
- D. Chen and D. Sarid, "An STM study of C_{60} adsorption on Si(100)-(2×1) surfaces: from physisorption to chemisorption," *Surf. Sci.* **329**, 206 (1995).
- D. Chen, R. K. Workman, and D. Sarid, "Fabrication of SiC films on Si(100) using a C_{60} molecular source," *Electr. Lett.* **30**, 1007 (1994).
- D. Sarid and D. Chen, "Interaction of C_{60} molecules with silicon surfaces and the formation of SiC films," *Nanotechnology* (in print 1995).
- D. Chen, R. K. Workman, and D. Sarid, "Growth mechanism of silicon carbide films on silicon substrates using C_{60} carbonization," *Surf. Sci.* (in print 1995).
- D. Chen, R. K. Workman, and D. Sarid, "Adsorption and decomposition of C_{60} molecules on Si(111) surfaces," *STM95*.
- X. Yao, D. Chen, T. G. Ruskell, R. K. Workman, and D. Sarid, "Thermally-induced changes in bonding properties of C_{60} on Si(100)-(2×1) surfaces," *Israeli J. Chem.*, (1995).

2 Scanning Force Microscopy

2.1 Review

- D. Sarid and V. Elings, "Review of scanning force microscopy," *J. Vac. Sci. Technol. B* **9** (2), 431 (1991).
- Dror Sarid, *Scanning Force Microscopy, With Applications to Electric, Magnetic, and Atomic Forces* (Oxford University Press, 1991).
- Dror Sarid, *Scanning Force Microscopy, With Applications to Electric, Magnetic, and Atomic Forces* (Oxford University Press, Revised Edition, 1994).

2.2 Laser Diode Interferometry

- D. Sarid, D. Iams, V. Weissenberger, and L. S. Bell, "Compact scanning force microscope using a diode laser," *Opt. Lett.* **28**, 335 (1988).
- D. Sarid, V. Weissenberger, D. A. Iams, and J. T. Ingle, "Theory of the laser diode interaction in a scanning force microscope," *IEEE J. Quantum Electron.* **25**, 1968 (1989).
- D. Sarid, D. Iams, J. Ingle, V. Weissenberger, and J. Ploetz, "Performance of a scanning force microscope using a laser diode," *J. Vac. Sci. Technol.* **8**, 378 (1989).
- D. Sarid, P. Pax, D. Bocek, and V. Elings, "Laser diode delivers atomically-resolved images," *Optics and Photonics News* **3**, 35 (1992).
- D. Sarid, P. Pax, L. Yi, S. Howells, M. Gallagher, T. Chen, V. Elings, and D. Bocek, "Improved atomic force microscope using a laser diode interferometer," *Rev. Sci. Instrum.* **63**, 3905 (1992).
- D. Sarid, D. Iams, V. Weissenberger, and L. S. Bell, "Compact scanning force microscope using a laser diode," *Selected Papers on Scanning Probe Microscopes Design and Applications*, SPIE Milestone Series **MS107**, 210 (1995).
- D. Sarid, "Laser Diode Detection," section in *Procedures in Scanning Probe Microscopy*, John Wiley and Sons (1995).

2.3 Combined AFM-STM

- S. Howells, M. Gallagher, L. Yi, T. Chen, and D. Sarid, "Enhanced effects with scanning force microscopy," *J. Appl. Phys.* **69**, 7330 (1991).
- L. Yi, D. Sarid, S. Howells, M. Gallagher, and T. Chen, "Combined STM-AFM for magnetic applications," *AIP Conf. Proc., Scanned Probe Microscopies* **241**, 537 (1992).
- T. G. Ruskell, R. K. Workman, D. Chen, S. Gilbert, S. Dahl and D. Sarid, "High resolution Fowler-Nordheim field emission maps of thin silicon oxide layers," *Appl. Phys. Lett.* (in print 1995).

2.4 Tapping-Mode AFM

- J. Chen, R. K. Workman, D. Sarid, and Ralf Höper, "Numerical simulations of a scanning force microscope with a large-amplitude vibrating cantilever", *Nanotechnology*, 5, 199 (1994).
- D. Sarid, J. Chen, and R. K. Workman, "Numerical simulations of a tapping mode scanning force microscope operating in a liquid", *Comp. Mat. Sci.* 3, 475 (1995).
- D. Sarid, "Tapping-mode scanning force microscopy: Metallic tips and samples," *Comp. Mat. Sci.* (in print, 1995).
- D. Sarid, T. G. Ruskell, R. K. Workman, and D. Chen, "Driven nonlinear AFM cantilevers: from noncontact to tapping modes of operation," In print, STM95 (1996).